

Application No. 10/674,372
Amendment filed: June 1, 2006
Reply to Office Action of March 17, 2006
Attorney's Docket No.: 042390.P15995

Patent



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

Frederick Haubbensak

Application No: 10/674,372

Filed: September 29, 2003

For: WAFER DEFECT REDUCTION BY
SHORT PULSE LASER ABLATION

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) Examiner: Elve, Maria Alexandria
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) Art Unit: 1725
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P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

This is in response to the Final Office Action mailed March 17, 2006 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Preliminary Amendment and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP RCE
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Signature

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Date